

Title (en)

Method of finely polishing planar optical elements.

Title (de)

Verfahren zur Feinpolieren von flachen optischen Elementen.

Title (fr)

Procédé de polissage fin d'éléments optiques plan.

Publication

EP 0608730 A1 19940803 (EN)

Application

EP 94100543 A 19940115

Priority

US 1134393 A 19930129

Abstract (en)

The present invention relates to a method of finely polishing an optically transparent surface with a polishing liquid containing abrasive particles. The polishing mixture, while subjected to ultrasonic agitation, is contacted with an optically transparent surface under conditions effective to polish finely that surface. The abrasive particles typically have a size of up to 1 micron. This process is particularly useful in smoothing the optically transparent surfaces which define cavities or sidewalls for planar optical elements in optical waveguides. <IMAGE>

IPC 1-7

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Citation (search report)

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